

# UAr Cryogenics Status

Forti Committee Meeting – Breakout Session

24 June 2024

Guillaume Plante, for the UAr Cryogenics WG

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# UAr Cryogenics: Overall Progress

- Advances since the last review meeting
  - Continued progress in reviewing and finalizing the UAr cryogenics P&ID
  - Work on detailed analyses of the main operating modes (recovery)
    - A few modifications to the P&ID from the analysis of the recovery operation mode
    - Greater confidence in system achieving intended functionality, reduction of potential technical risks
  - Work on interplay between AAr and UAr systems during cool down, filling, and recovery
    - Developed a combined description of the main procedural steps, which system sets pace when, alarms, interlocks
    - Defined interfaces (exchanged process variables) and required functional logic based on this combined description
  - Theoretical calculations to validate existing components or guide the sizing / detailed design
    - Heat transfer in two-phase vertical tube banks heat exchangers
  - Mockup
    - Successful completion of cryogenics test runs (talk by Kevin Thieme)
  - Radon trap
    - Two test benches built: one to measure radon dynamic adsorption coefficient as a function of temperature and flow; one to measure the flow resistance properties of the candidate charcoal adsorbents
  - Slow control
    - Started describing the interfaces between the DS-20k Detector Control System, Detector Safety System and the UAr cryogenics basic control system
  - Procurement
    - Ready to place order for some long lead-time items: getter gas purifier, UHP valves



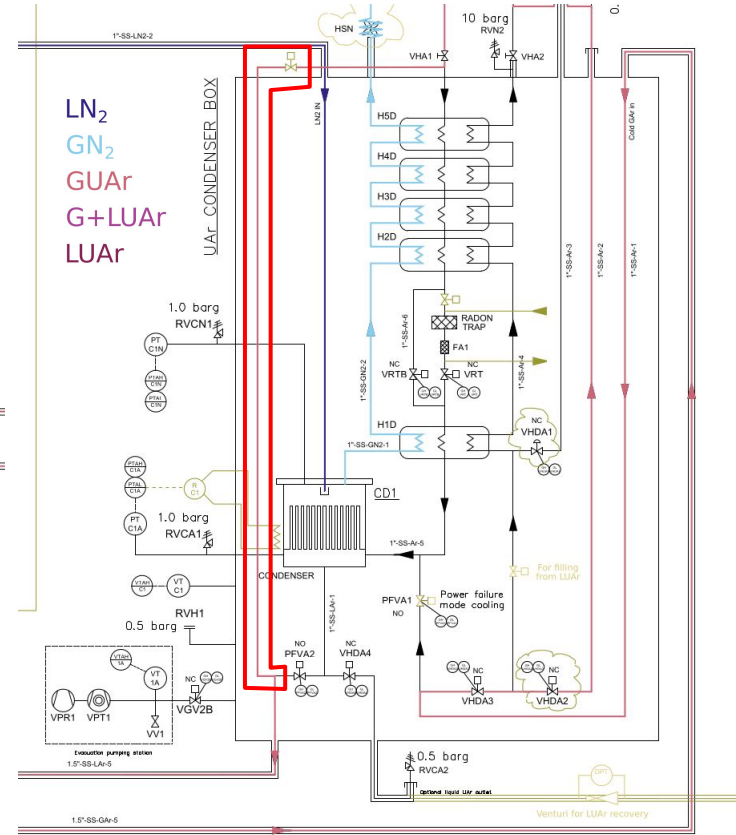
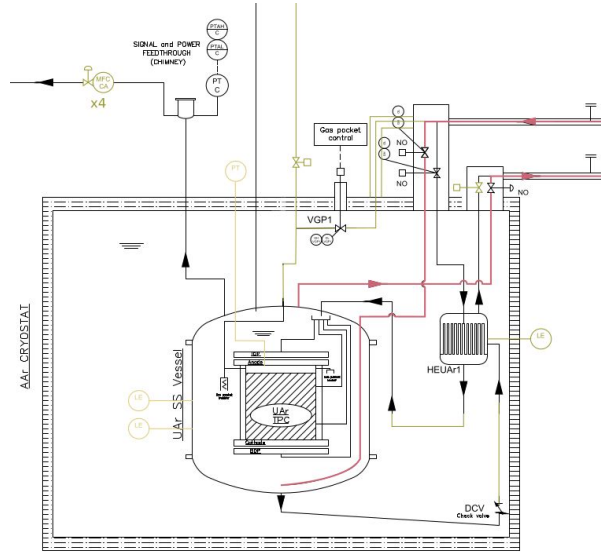
# UAr Cryogenics: P&ID Updates

- P&ID revision in the final stages of release
- Modifications in this revision
  - Update of tags according to ANSI/ISA S5.1 and ISO 14617-6 standards
  - Addition of a pressure control valve in parallel to VMFN2 with a flow coefficient sized for lower cooling power operation (e.g. photoelectronics off). Also, addition of a manual PCV for a last resort manual control.
  - Addition of an electrical heater on condenser to eliminate technical risk of cooling at zero N2 flow (and as an emergency defrost)
  - Added an on/off valve between the LUAr source flow control valve VHDA1 and the GUAr flow out of the UAr vessel
  - Added an on/off valve and line bypassing CD1 to provide heat to the UAr volume during recovery
  - Added level transmitters to the UAr vessel and to the HEUAr1 heat exchanger
  - Other minor piping modifications/simplifications
    - Addition of an on/off valve on the GUAr outlet of HEUAr1
    - Moved S2 gas pocket flow control valve VGP1 inlet to the GUAr volume of the line from CD1
    - Reverted PFVA1 to an on/off valve
    - Removal of gas pump QDC1 on the chimney GUAr outlets
    - Substitution of flow meter MFMCE with three mass flow controllers
    - Change LN2 supply valves VPLNS1/2 to proportional valves
    - Modifications to the calibration sources injection piping



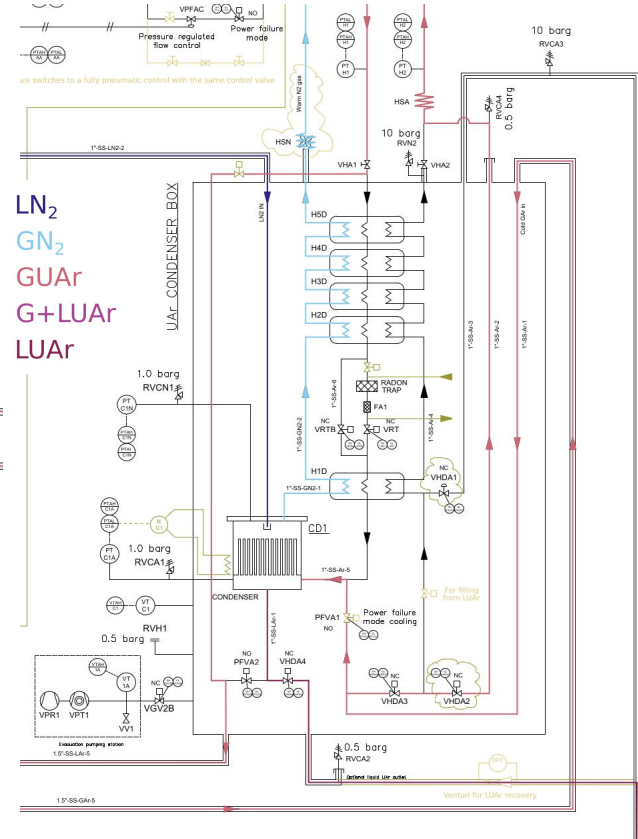
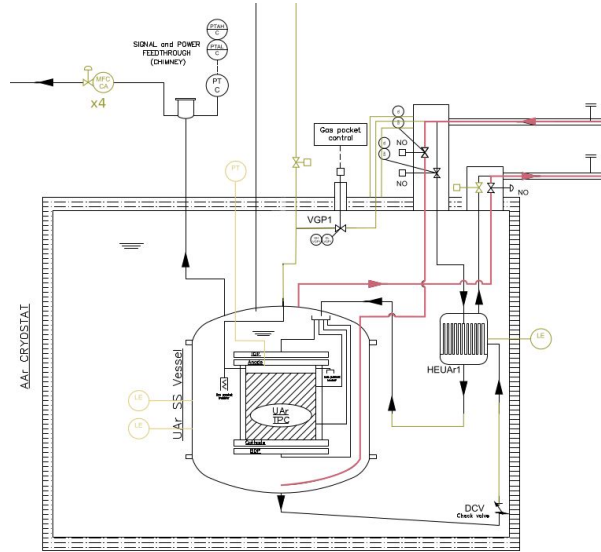
# UAr Cryogenics: P&ID Updates

- Recovery mode, GUAr to storage
  - Previous revision had not been analyzed thoroughly yet
  - Bring heat to the LUAr volume of the UAr vessel by injecting warm GUAr through the “filling” tube at the bottom
- Changes
  - Added valve and line bypassing CD1



# UAr Cryogenics: P&ID Updates

- Recovery mode, LUAr to storage, start
  - New mode where the cooling power of CD1 is used to condense the GUAr extracted from the UAr vessel and route the LUAr to storage.
  - Bring heat to the LUAr volume of the UAr vessel by injecting warm GUAr through the “filling” tube at the bottom



# UAr Cryogenics: UAr / AAr Coordination During Filling

- At a high level, the overall filling operation can be thought of being composed of the phases:

Phase	AAr	UAr	Notes
Preparation	GAAr Purge	<ol style="list-style-type: none"><li>1. Evacuate</li><li>2. Fill GUAr</li><li>3. Recirculate GUAr</li></ol>	Delay purge operation
Cool Down	Cool Down	Slow GUAr cool down	UAr limits AAr cool down rate
Filling 1	Fill LAAr until height H0 of SS vessel	Fill minimal LUAr quantity	LAAr availability sets pace
Filling 2	Semi-synchronous LAAr/LUAr filling until height H1 of SS vessel	Semi-synchronous LAAr/LUAr filling until height H1 of SS vessel	Maintain differential height below limit
Filling 3	Complete LAAr filling	Normal operation	



# UAr Cryogenics: UAr / AAr Coordination During Filling

- Started defining list of alarms and interlocks that are always active and relevant to cryogenic operations

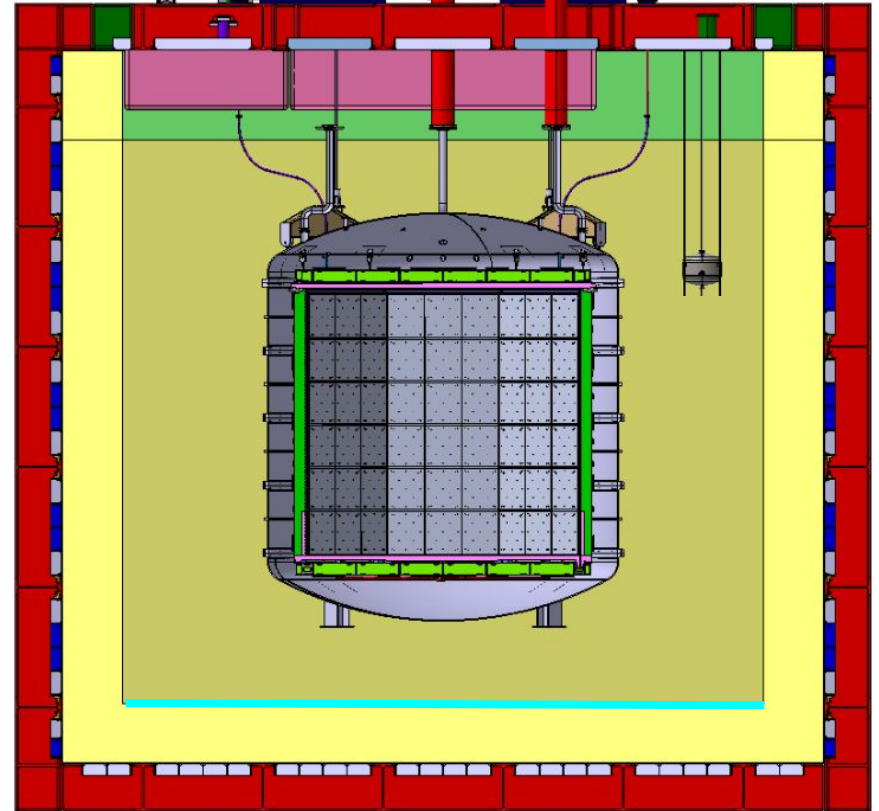
TABLE 2: ALARMS AND INTERLOCKS ALWAYS ACTIVE			
NAME	P&ID TAGS	DESCRIPTION	NOTES
UAr.PRESSURE.H	PTAA, PTAB	High alarm on the UAr SS vessel pressure, interlock that activates the UAr system no-power mechanical pressure control system	Warns the operator of a potential UAr vessel overpressure scenario
UAr.PRESSURE.HH	PTAA, PTAB	High high alarm on the UAr SS vessel pressure, interlock that stop heat flows into UAr SS vessel, e.g., stops gas circulation pumps	Warns the operator of a potential UAr vessel overpressure scenario, attempts to limit further pressure increases
UAr.PRESSURE.L	PTC1A	Low alarm on the UAr cryogenic system condenser pressure, interlock that activates the condenser heater system	Warns the operator of a potential UAr cryogenic system condenser overcooling scenario
UAr.RD1.H	PT1A	High alarm on the UAr SS vessel pressure relief safety vent pressure	Warns operator that pressure relief safety device RD1A is either malfunctioning or has burst
LN2.MASS.L	TBD	Low alarm on the LN <sub>2</sub> mass available in storage	Warns operator, e.g., that the LN <sub>2</sub> consumption has been in excess of re-liquefaction capacity
LN2.PRESSURE.L	TBD	Low alarm on the LN <sub>2</sub> storage supply pressure	Warns operator of, e.g., potential malfunction in the LN <sub>2</sub> supply system
UAr.VESSEL.LOAD.H	TBD	High alarm on the downward force on the UAr SS vessel support system	Warns operator of, e.g., a filled mass in the UAr SS vessel approaching its limit
UAr.VESSEL.LOAD.L	TBD	Low alarm on the downward force on the UAr SS vessel support system	Warns operator of, e.g., a buoyancy force on the UAr SS vessel approaching its limit



# UAr Cryogenics: UAr / AAr Coordination During Filling

- Cool down
  - GUAr slow cool down
  - As fast as the most fragile component allows
  - Monitor T gradients
- Alarms

TABLE 3: ALARMS AND INTERLOCKS ACTIVE DURING THE COOL DOWN PHASE			
NAME	P&ID TAGS	DESCRIPTION	NOTES
UAR.COOLING_RATE.H	TBD	High alarm on the cooling rate of the gaseous UAr inside the SS vessel	Warns operator if the cooling rate achieved is larger than desired
VESSEL.COOLING_RATE.H	TBD	High alarm on the UAr SS vessel cooling rate	Warns operator that the UAr SS vessel cooling rate is faster than desired, operator should reduce the AAr cryostat cool down
TPC.DTDX1.H	TBD	Generic high alarm on a spatial temperature gradient	Warns operator if a temperature gradient across a critical component or components is approaching the limit
TPC.DTDX1.HH	TBD	Generic high high alarm on a spatial temperature gradient, interlock that stops or reduces the cooling	Ensures that a temperature gradient across a critical component or components stops increasing the cooling

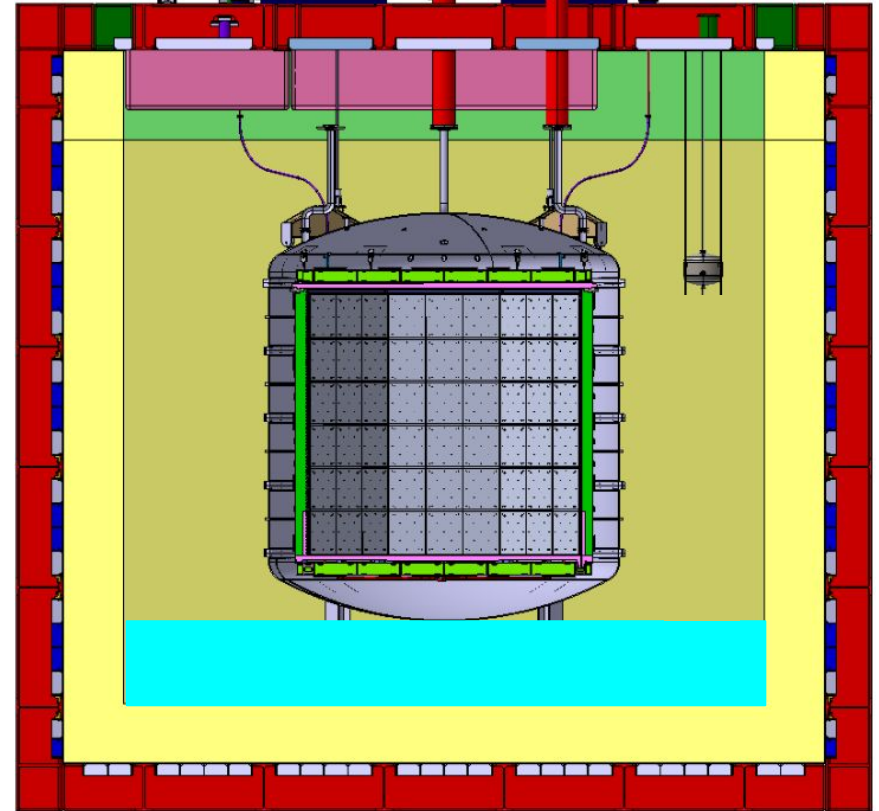




# UAr Cryogenics: UAr / AAr Coordination During Filling

- Filling 1
  - Fill LAAr until height  $H_0$  of SS vessel
  - $H_0$  such that we can fill a minimal amount of LUAr in the SS vessel
  - Pace set by the availability of LAAr trucks
- Alarms

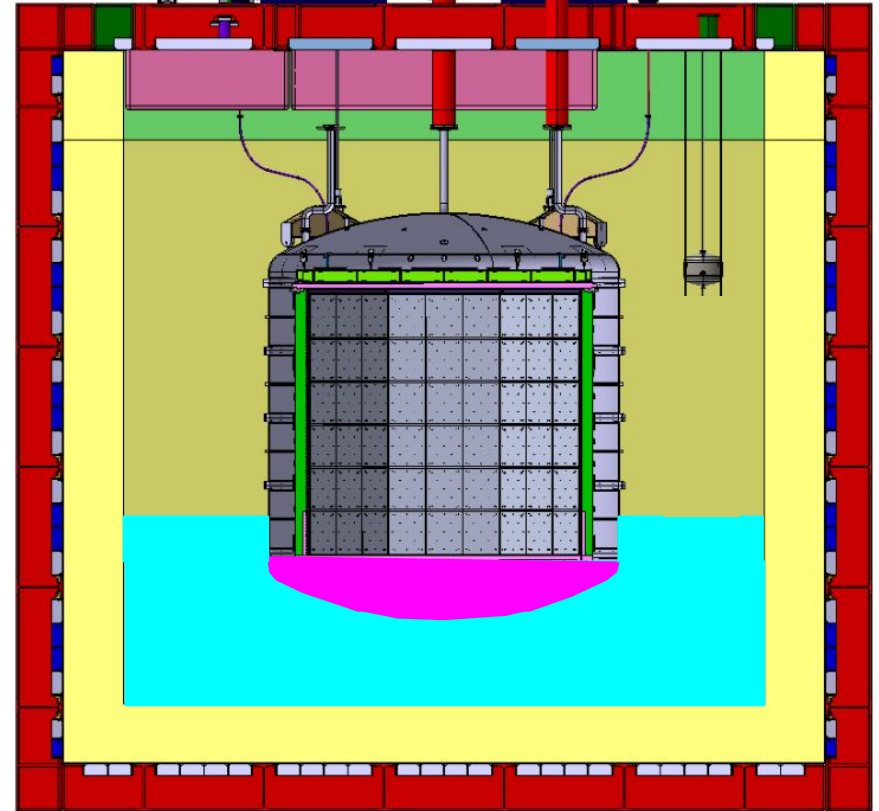
TABLE 4: ALARMS AND INTERLOCKS ACTIVE DURING THE FILLING 1 PHASE			
NAME	P&ID TAGS	DESCRIPTION	NOTES
AAR_UAR_DELTAP_H	PTAA, PT4910	High alarm on differential pressure between the AAr cryostat and the UAr SS vessel	Warns operator, e.g., of excess cooling power on the UAr volume or insufficient cooling power on the AAr volume
AAR_UAR_DELTAP_L	PTAA, PT4910	Low alarm on differential pressure between the AAr cryostat and the UAr SS vessel	Warns operator of the reverse situation as above
AAR_UAR_DELTAL_H	PDT4915, TBD	High alarm on liquid level difference between the AAr cryostat and the UAr SS vessel	Warns operator, e.g., that the AAr filling speed is faster than desired
AAR_LEVEL_H0_H	PDT4915	High alarm on AAr cryostat liquid level	Warns operator that the desired AAr liquid level ( $H_{\text{vessel}} + H_0$ ) has been reached and that the Filling 1 phase has been completed



# UAr Cryogenics: UAr / AAr Coordination During Filling

- Filling 2
  - Semi-synchronous LAAr/LUAr filling until height  $H_1$  of SS vessel
  - Filling rate limited by UAr cryogenics
- Alarms

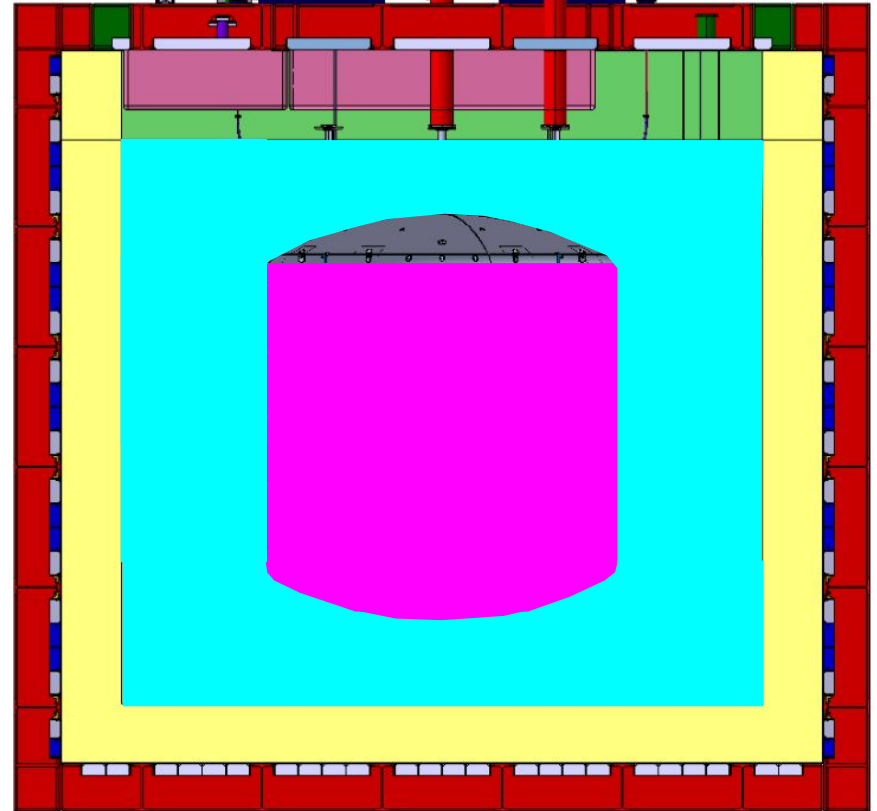
TABLE 5: ALARMS AND INTERLOCKS ACTIVE DURING THE FILLING 2 PHASE			
NAME	P&ID TAGS	DESCRIPTION	NOTES
AAR_UAR_DELTAP_H	PTAA, PT4910	High alarm on differential pressure between the AAr cryostat and the UAr SS vessel	Warns operator, e.g., of excess cooling power on the UAr volume or insufficient cooling power on the AAr volume
AAR_UAR_DELTAP_L	PTAA, PT4910	Low alarm on differential pressure between the AAr cryostat and the UAr SS vessel	Warns operator of the reverse situation as above
AAR_UAR_DELTAL_H	PDT4915, TBD	High alarm on liquid level difference between the AAr cryostat and the UAr SS vessel	Warns operator, e.g., that the AAr (UAr) filling speed is faster (slower) than desired
AAR_UAR_DELTAL_L	PDT4915, TBD	Low alarm on liquid level difference between the AAr cryostat and the UAr SS vessel	Warns operator, e.g., that the AAr (UAr) filling speed is slower (faster) than desired
LN2_DMDT_H	TBD	High alarm on the LN <sub>2</sub> consumption rate	Warns operator, e.g., that the current LN <sub>2</sub> consumption rate might not be sustainable for a long period, that the AAr and/or the UAr filling speeds should be reduced, etc
UAR_LEVEL_H1_H	TBD	High alarm on UAr SS vessel liquid level	Warns operator, e.g., that the desired UAr liquid level ( $H_1$ ) has been reached and that the Filling 2 phase has been completed



# UAr Cryogenics: UAr / AAr Coordination During Filling

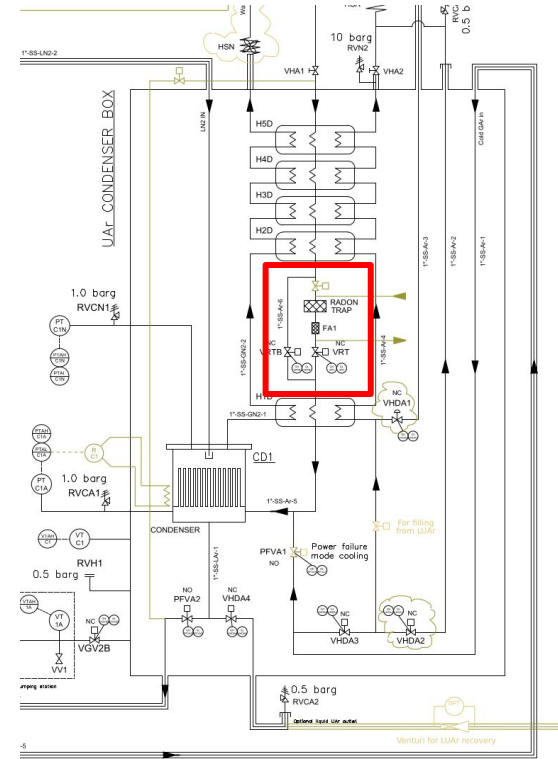
- Filling 3
  - Complete LAAr filling
  - UAr cryogenic system can be put in normal operation mode
- Alarms

TABLE 6: ALARMS AND INTERLOCKS ACTIVE DURING THE FILLING 3 PHASE			
NAME	P&ID TAGS	DESCRIPTION	NOTES
AAR_UAR_DELTAP_H	PTAA, PT4910	High alarm on differential pressure between the AAr cryostat and the UAr SS vessel	Warns operator, e.g., of excess cooling power on the UAr volume or insufficient cooling power on the AAr volume
AAR_UAR_DELTAP_L	PTAA, PT4910	Low alarm on differential pressure between the AAr cryostat and the UAr SS vessel	Warns operator of the reverse situation as above
AAR_LEVEL_H2_H	PT4910	High alarm on AAr cryostat liquid level	Warns operator, e.g., that the desired AAr liquid level ( $H_2$ ) has been reached and that the Filling 3 phase has been completed

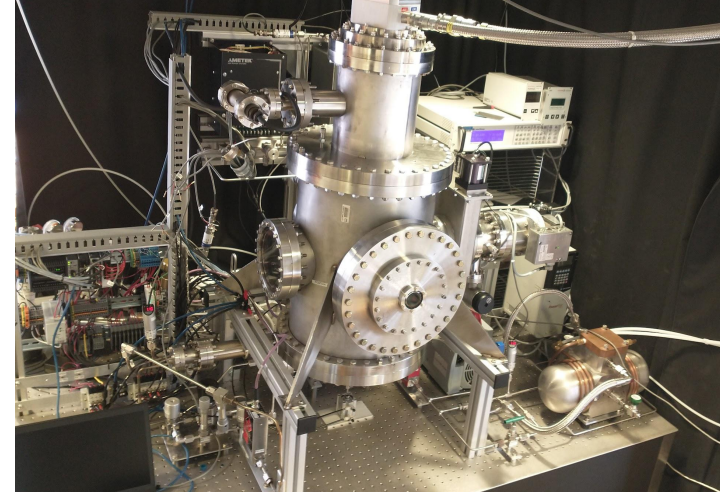
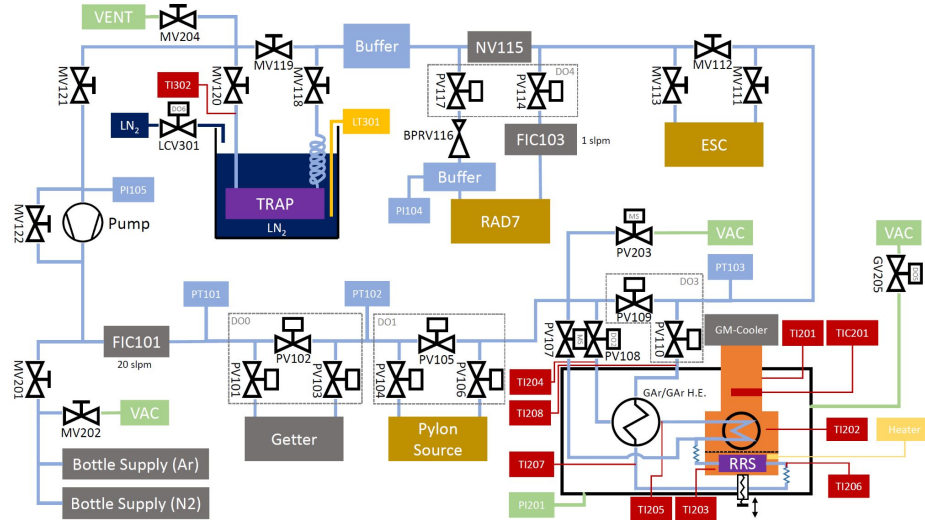


# UAr Cryogenics: Radon Trap

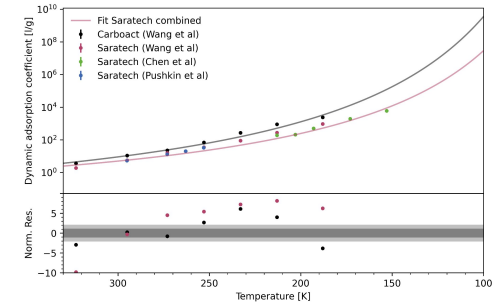
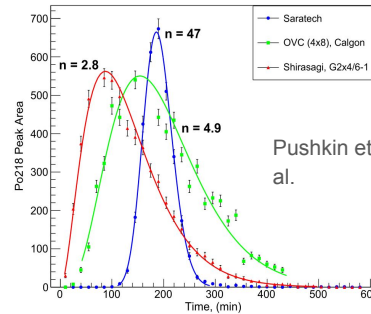
- Planned to be in the UAr purification loop return path the TPC
  - Installed between GUAr/GUAr heat exchangers H2D and H1D
  - Temperature of operation  $\approx 100$  K
  - Particulate filter installed downstream
- We want a predictable performance both in terms of radon removal and flow resistance.
- Activated charcoal suitability/QA tests
  - Specific activity of an adsorbent mBq/kg (relying on other collaboration facilities).
  - Radon dynamic adsorption coefficient and its temperature dependence.
  - Flow resistance tests to construct an adequate model of the pressure drop versus flow for a given radon trap geometry.
- Built two test benches:
  - Radon trap test bench to measure the radon dynamic adsorption coefficient as a function of temperature and flow
  - Flow resistance test bench to measure the pressure drop across various cylindrical trap geometries with different adsorbents



# UAr Cryo Updates: Radon Trap

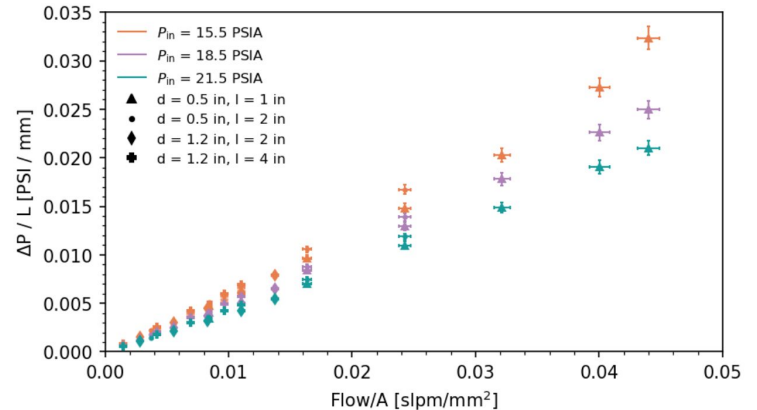


- Strategy:
  - Measure charcoal radon dynamic adsorption coefficient with Ar carrier gas at different T
  - Design a trap with a (statistically) known radon removal performance and as low as reasonably achievable pressure drop



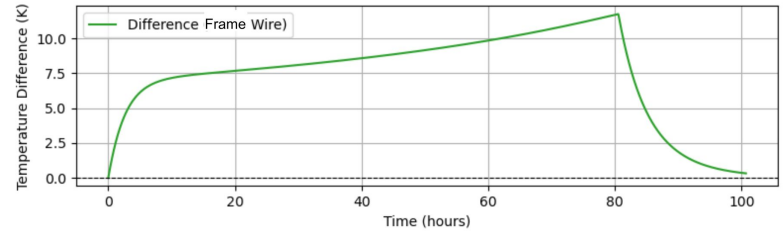
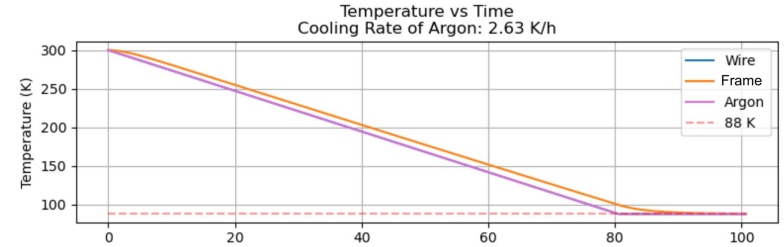
# UAr Cryogenics: Radon Trap

- Procurement
  - Charcoal adsorbents sample from CarboAct for QA testing in hand
  - Charcoal adsorbents from Talamon GmbH for QA testing in hand
    - More than enough for tests and for the production trap
- Flow resistance test bench
  - Completed tests for the Talamon ( $\phi = 0.4$  mm) adsorbent.
  - Parameters extracted allow us to reliably predict the maximum pressure drop of a given radon trap geometry.
- DS-20k trap design
  - Algorithm elaborated for sizing and detailed design.
    - Takes as input key DS-20k specifications, results of QA tests; prescribes a trap geometry that fulfills the radon reduction while satisfying pressure drop requirement.
- Status
  - Talamon ( $\phi = 0.4$  mm) adsorbent sample shipped for radon emanation measurement
  - Start measuring dynamic radon adsorption coefficients this summer
  - Finalize trap design and start fabrication Q4-24



# UAr Cryogenics: Cool Down Estimates

- Work on estimating temperature gradients in different cooling scenarios
  - Work in a simplified geometry, assumptions on boundary conditions (insulated, HTC, etc)
  - Use HTC correlations appropriate for the problem
  - Calculate temperature gradients as a function of the GUAr cooling rate
- Goal: have the means to determine a cooling rate that satisfies  $\Delta T$  constraints (with safety margin)
- Examples:
  - Mockup:  $\Delta T$  between grid wire and frame
    - Natural convection HTC for cylinder in gas at fixed temperature
    - Linearly decreasing GUAr volume temperature
  - Mockup:  $\Delta T$  within PMMA panels
    - Natural convection HTC for vertical slab in gas at fixed temperature



**Wire:** L = 0.68 m and d = 0.15 mm.

**Frame:** L = 2.63 m and d = 13 mm

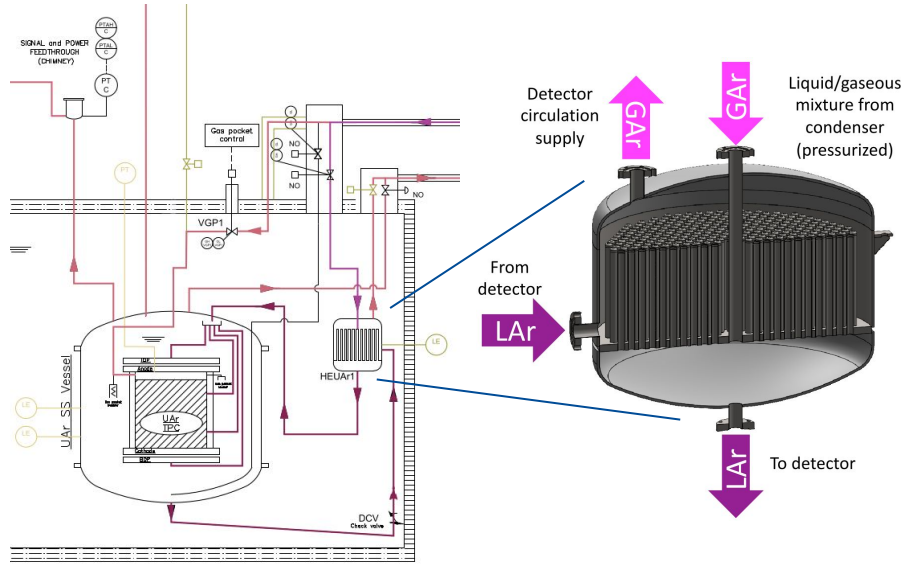
$$\frac{dT}{dt} = -h(T, t) \times A \times \frac{T - T_{Ar}(t)}{m \times c}$$

$$h(T, t) = \left( \frac{k_{Ar}(t)}{d} \right) \times \left( 0.6 + \frac{0.387 \times (Ra(T, t))^{\frac{1}{4}}}{\left( 1 + \left( \frac{0.559}{(Pr(t))^{\frac{1}{4}}} \right)^{\frac{8}{27}} \right)^2} \right)$$

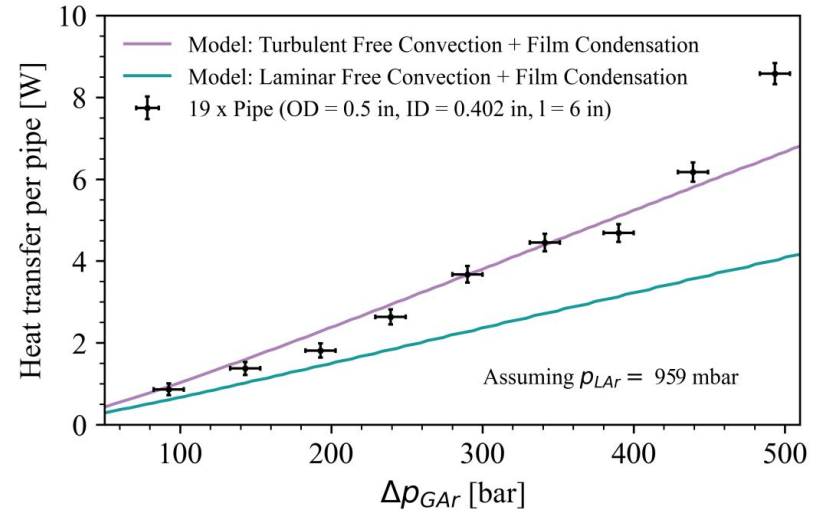


# UAr Cryogenics: Two-Phase HE Modeling/Design

- Progress on modelling the heat transfer inside the two-phase HE of the proposed design
- Very good agreement with data if we assume:
  - HTC correlation for film condensation on a vertical wall
  - HTC correlation for turbulent free convection in the liquid



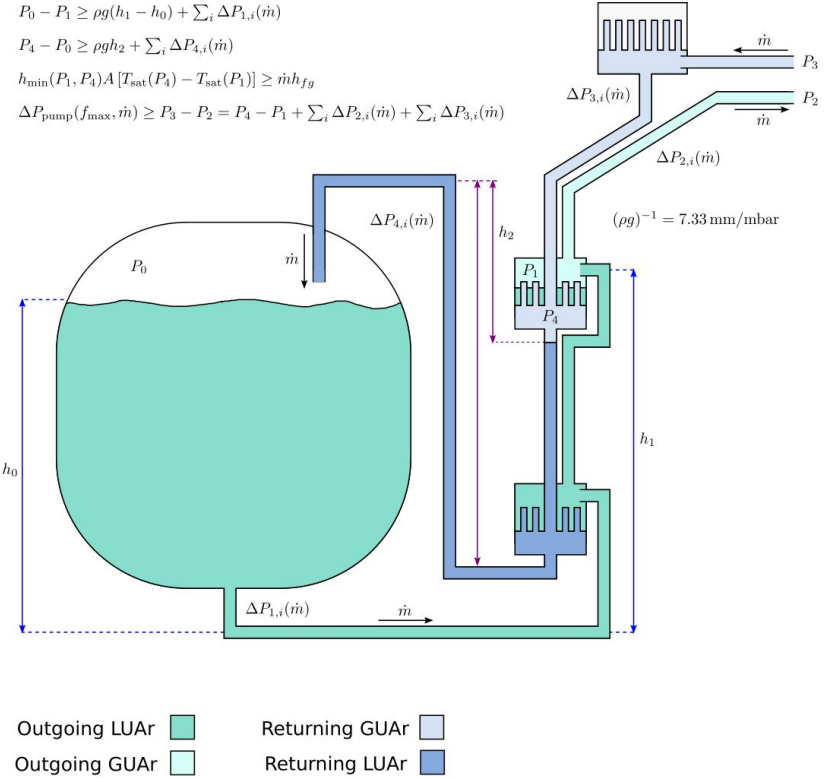
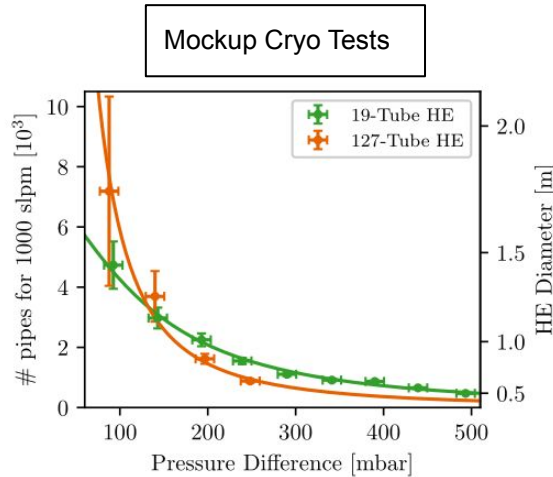
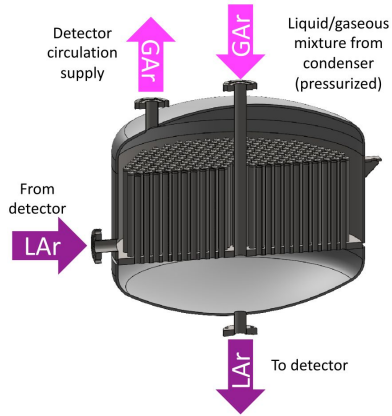
Compare Model to Data from 19 pipe measurements at CERN





# UAr Cryogenics: Two-Phase HE Modeling/Design

- Conditions that have to be fulfilled for the purification loop to function established
- In a good position to dimension and position HE appropriately, choose reliable safety margins



# UAr Cryogenics: Upcoming Activities

- Basic design
  - Complete a final cycle of analyses of system operational modes
  - Expect only minor P&ID modifications at this stage (e.g. additional sensors, etc).
- Detailed design
  - UAr continuous purification loop, two-phase heat exchangers, cryostat top valve box, etc
  - UAr condenser box modifications (radon trap, and anything else, as informed by mockup cryo tests)
  - Review of functional logic description for the basic control system
- Procurement
  - Place orders on long lead items (gas purifier, high-flow valves, etc)
  - Followed up by fabrication materials for UAr continuous purification loop
  - RFQs for gas circulation pumps
  - RFQs for fabrication of other main system components (two-phase HEs, LN2 supply, etc)
- Schedule
  - On track for delivery of UAr cryogenics major components to LNGS without affecting the critical path



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